
MECHANISMS & MECHANICAL DEVICES SOURCEBOOK

Third Edition

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ABOUT THE EDITORS

Neil Sclater began his career as an engineer in the military/aerospace industry and a Boston engineering consulting firm before changing his career path to writing and editing on electronics and electromechanical subjects. He was a staff editor for engineering publications in electronic design, instrumentation, and product engineering, including McGraw-Hill's *Product Engineering* magazine, before starting his own business as a consultant and contributing editor in technical communication.

For the next 25 years, Mr. Sclater served a diversified list of industrial clients by writing marketing studies, technical articles, brochures, and new product releases. During this period, he also directly served a wide list of publishers by writing hundreds of by-lined articles for many different magazines and newspapers on various topics in engineering and industrial marketing.

Mr. Sclater holds degrees from Brown University and Northeastern University, and he has completed graduate courses in industrial management. He is the author or coauthor of seven books on engineering subjects; six of these were published by McGraw-Hill's Professional Book Group. He previously revised and edited the Second Edition of *Mechanisms and Mechanical Devices Sourcebook* after the death of Mr. Chironis.

The late **Nicholas P. Chironis** developed the concept for *Mechanisms and Mechanical Devices Sourcebook*, and was the author/editor of the First Edition. He was a mechanical engineer and consultant in industry before joining the staff of *Product Engineering* magazine as its mechanical design editor. Later in his career, he was an editor for other McGraw-Hill engineering publications. He had previously been a mechanical engineer for International Business Machines and Mergenthaler Linotype Corporation, and he was an instructor in product design at the Cooper Union School of Engineering in New York City. Mr. Chironis earned both his bachelor's and master's degrees in mechanical engineering from Polytechnic University, Brooklyn, NY.

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